

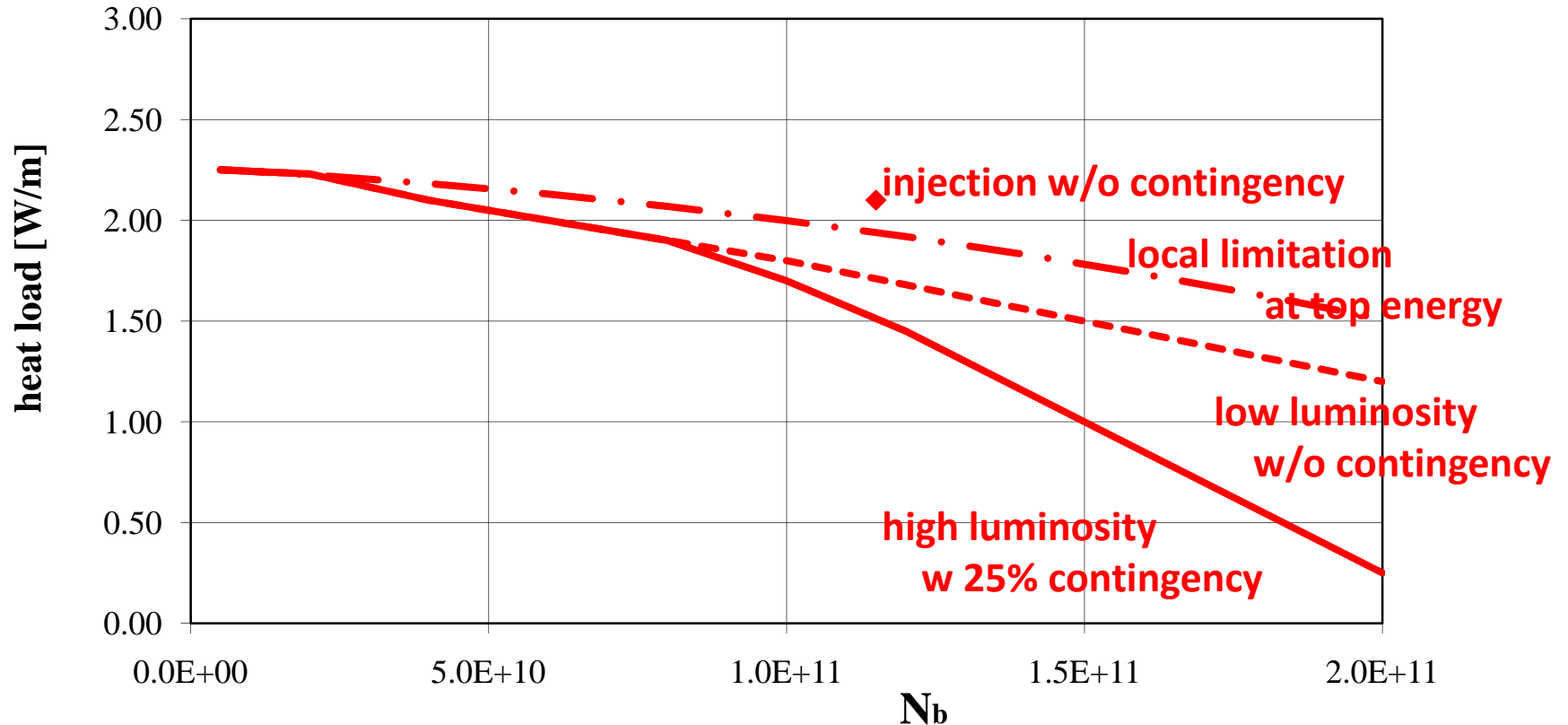
impact on e-cloud heat load of wrongly-oriented beam screens

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21 January 2009

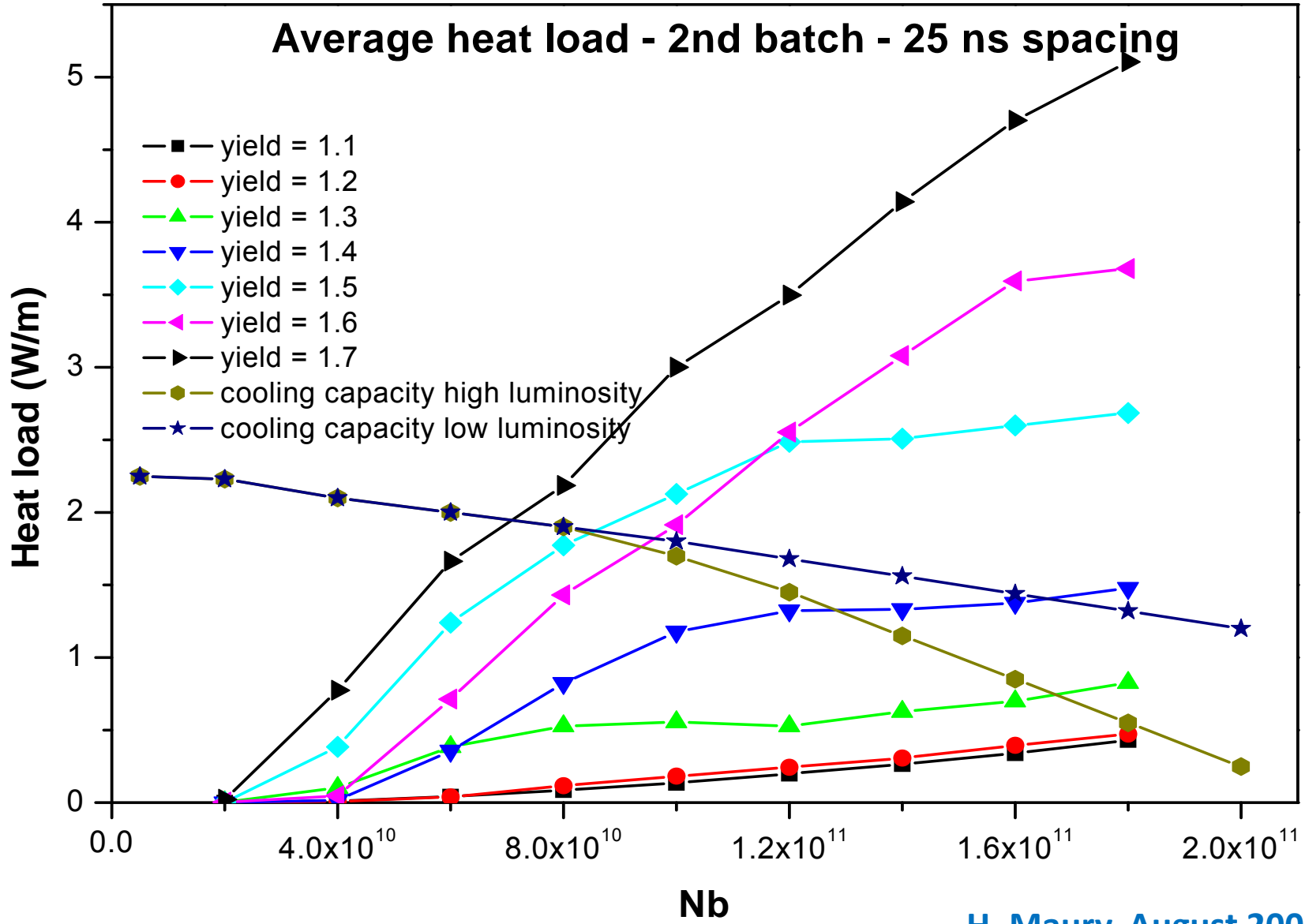
local & global cooling limits

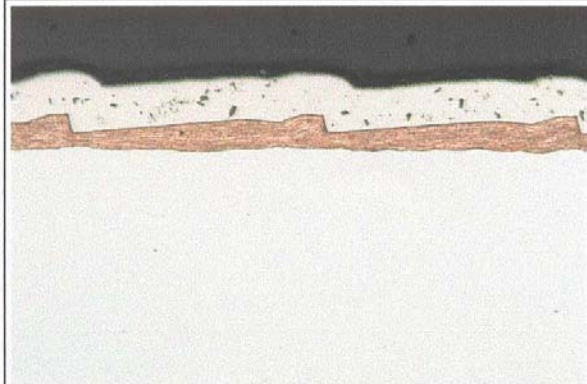
L. Tavian, B. Jeanneret, F.Z., 2005



if only a small number of magnets is concerned, the local limit will be more relevant

predicted heat load & average arc cooling capacity vs bunch intensity

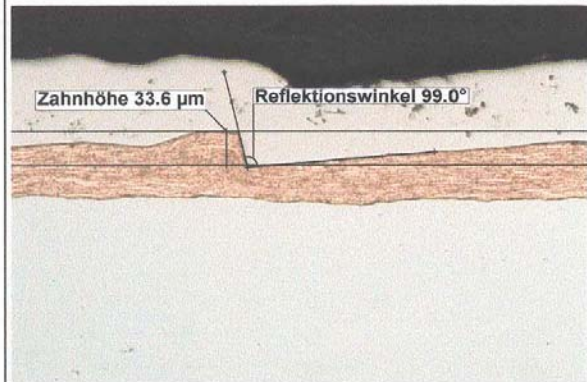




906P0467

Probe vom 17.06.99 -
Links

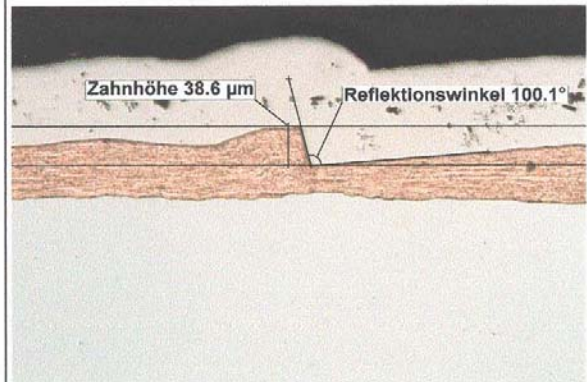
100 : 1



906P0468

Probe vom 17.06.99 -
Links

200 : 1



906P0471

Probe vom 17.06.99 -
Links

200 : 1

LHC
“sawtooth”
chamber

perpendicular
photon impact
→
reduced
photoemission
yield

effect of sawtooth on photo-electron yield & photon reflection

V. Baglin, I. Collins, O. Grobner,
 “Photoelectron Yield and Photon Reflectivity
 from Candidate LHC Vacuum Chamber
 Materials with Implications to the Vacuum
 Chamber Design”, LHC Project Report 206,
 1998

Table 1. Forward scattering photon reflection R and photoelectron yields per absorbed photon, Y^* , of the studied materials under different surface conditioning, irradiated by 45 eV and 194 eV critical energy synchrotron radiation.

Surface	Status	45 eV		194 eV	
		R (%)	Y^* (e/ph)	R (%)	Y^* (e/ph)
Cu co-lam.	as-received	80.9	0.114	77.0	0.318
	air baked	21.7	0.096	18.2	0.180
Cu elect.	as-received	5.0	0.084	6.9	0.078
Cu sawtooth	as-received	1.8	0.053	-	-
	150°C, 9h	1.3	0.053	1.2	0.052
	150°C, 24h	1.3	0.040	1.2	0.040

measurements at CERN EPA, 1998

V.V. Anashin, I.R. Collins, R.V. Dostovalov,
 N.V. Fedorov, O. Grobner, A.A. Krasnov, O.B.
 Malyshev, E.E. Pyata, “Magnetic and
 Electric Field Effects on the Photoelectron
 Emission from Prototype LHC Beam Screen
 Material”, LHC Project Report 373, 2001

Table 3: A summary of the measured reflectivities and photoelectron yields per absorbed photon. The critical energy at which the measurements were made is also indicated.

Sample	Critical Energy E_c (eV)	Forward Scattered Reflection		Diffuse Reflectivity R_{dif}	Photon Adsorption R_I	$\frac{R_{dif}}{R_I + R_{dif}}$	Y (electron/photon)
		R_e (by current)	R_W (by power)				
Smooth surface	20	0.67	—	0.04	0.29	0.13	0.03
Saw-tooth surface	49	0.035	—	0.22	0.74	0.23	0.049
	246	0.026	0.03	0.185	0.79	0.19	0.063

measurements at BINP VEPP-2M, 2001

sawtooth eliminates 70-80 % forward scattering, but introduces 20% diffuse scattering

effect of sawtooth on photon reflection (& energy distribution)

R. Cimino, V. Baglin, I.R. Collins, A. Giglia, N. Mahne, S. Nannarone, L. Pasquali, M. Pedio, “Photon Reflectivity Distributions from the LHC Beam Screen and their Implications on the Arc Beam Vacuum System”, LHC Project Report 668, 2004

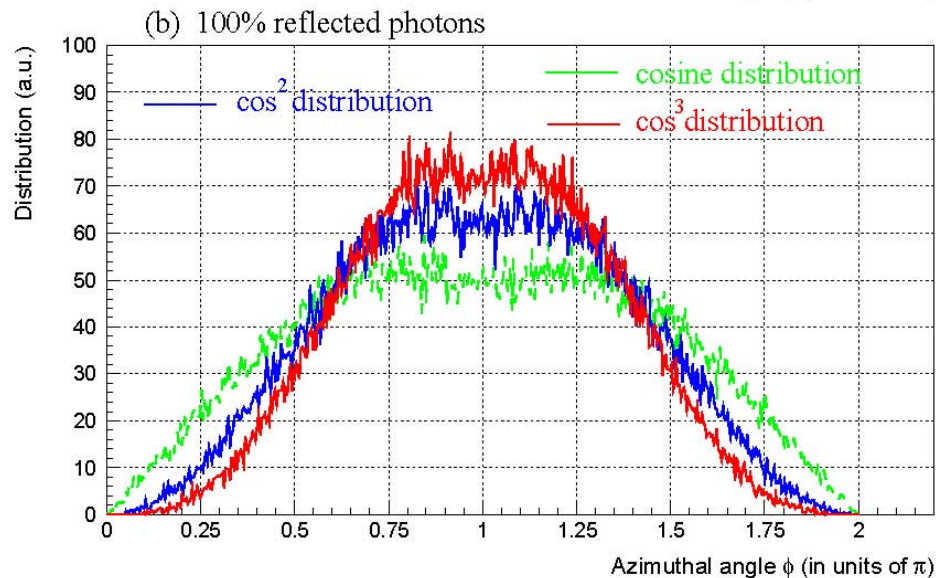
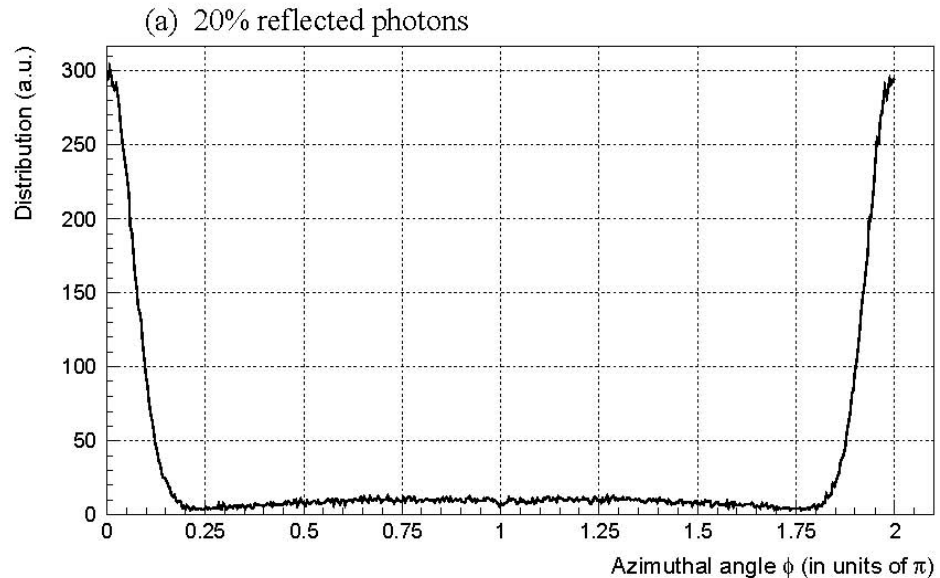
measurements at ELETTRA, 2003

	Flat sample	Saw-tooth sample
Forward scattering	80 %	4 %
Back scattering	0 %	2 %
Diffused	2 %	4 %
Total	82 %	10 %

only 4% diffuse scattering – why?

Table 1: Measured values of the forward scattering, back scattering and diffused light expressed in percentage of the incoming light.

angular
distribution
of emitted
photoelectrons
with
sawtooth
chamber,
assumed in
the simulation



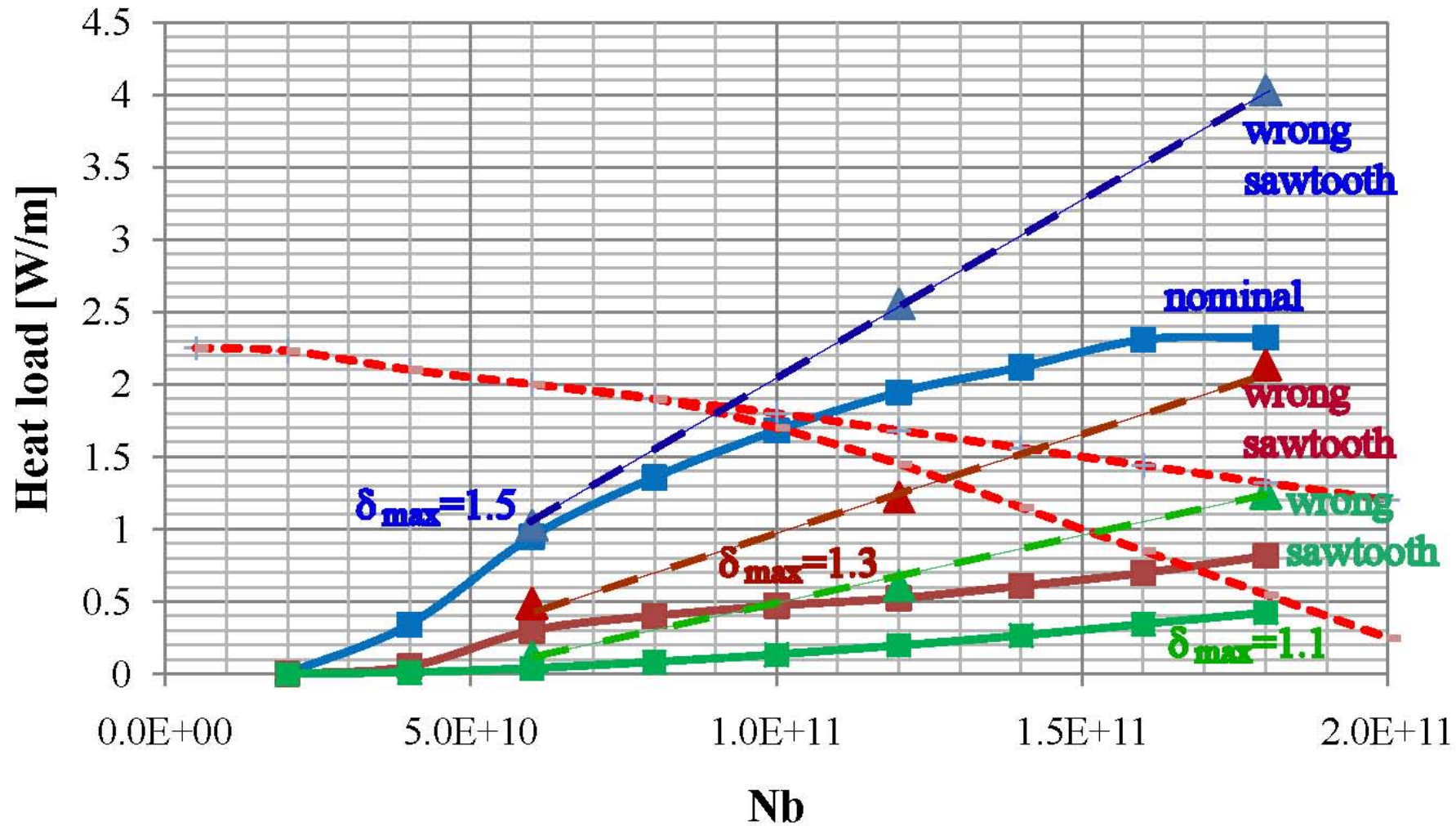
wrongly-oriented sawtooth chamber

- no measurement available
- perhaps plausible to assume both $\sim 20\%$ diffusive scattering and $60\text{-}70\%$ forward scattering
- to be conservative take \cos^2 distribution with 100% reflection
- also take 3 times larger photoelectron yield (rough estimate from CERN EPA data)

how much does the heat load change?

compute heat load in dipole w and w/o sawtooth and then scale arc heat load starting from Humberto's result

global limit (assuming all arc magnets have wrong orientation)

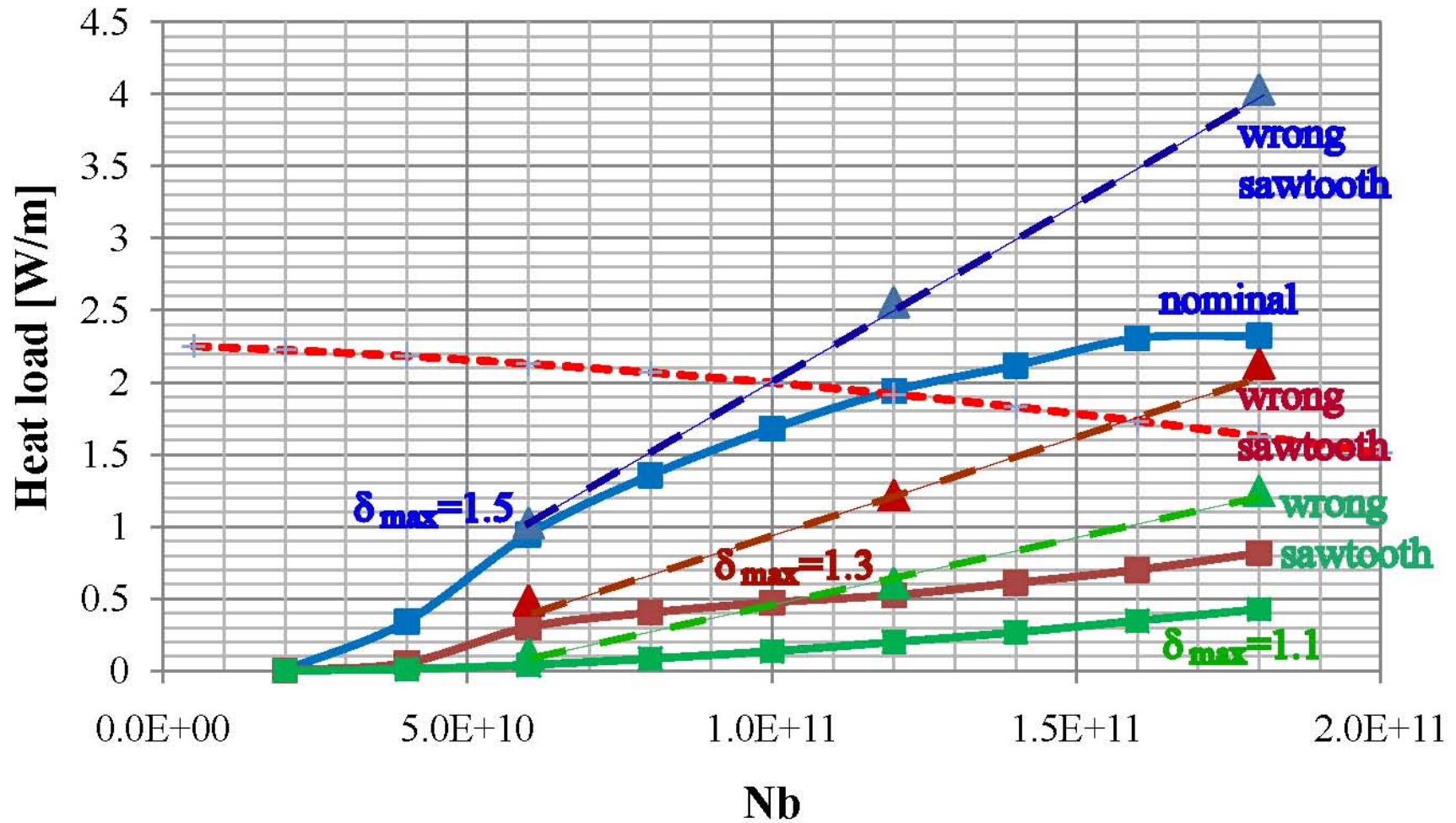


for $\delta_{\max}=1.5$: $N_{\max} \sim 10^{11} \rightarrow 9 \times 10^{10}$

for $\delta_{\max}=1.3$: $N_{\max} \sim 1.6 \times 10^{11} \rightarrow 1.2 \times 10^{11}$

for $\delta_{\max}=1.1$: $N_{\max} \sim 1.8 \times 10^{11} \rightarrow 1.5 \times 10^{11}$

local limit (assuming all magnets in 1 half cell have wrong orientation)



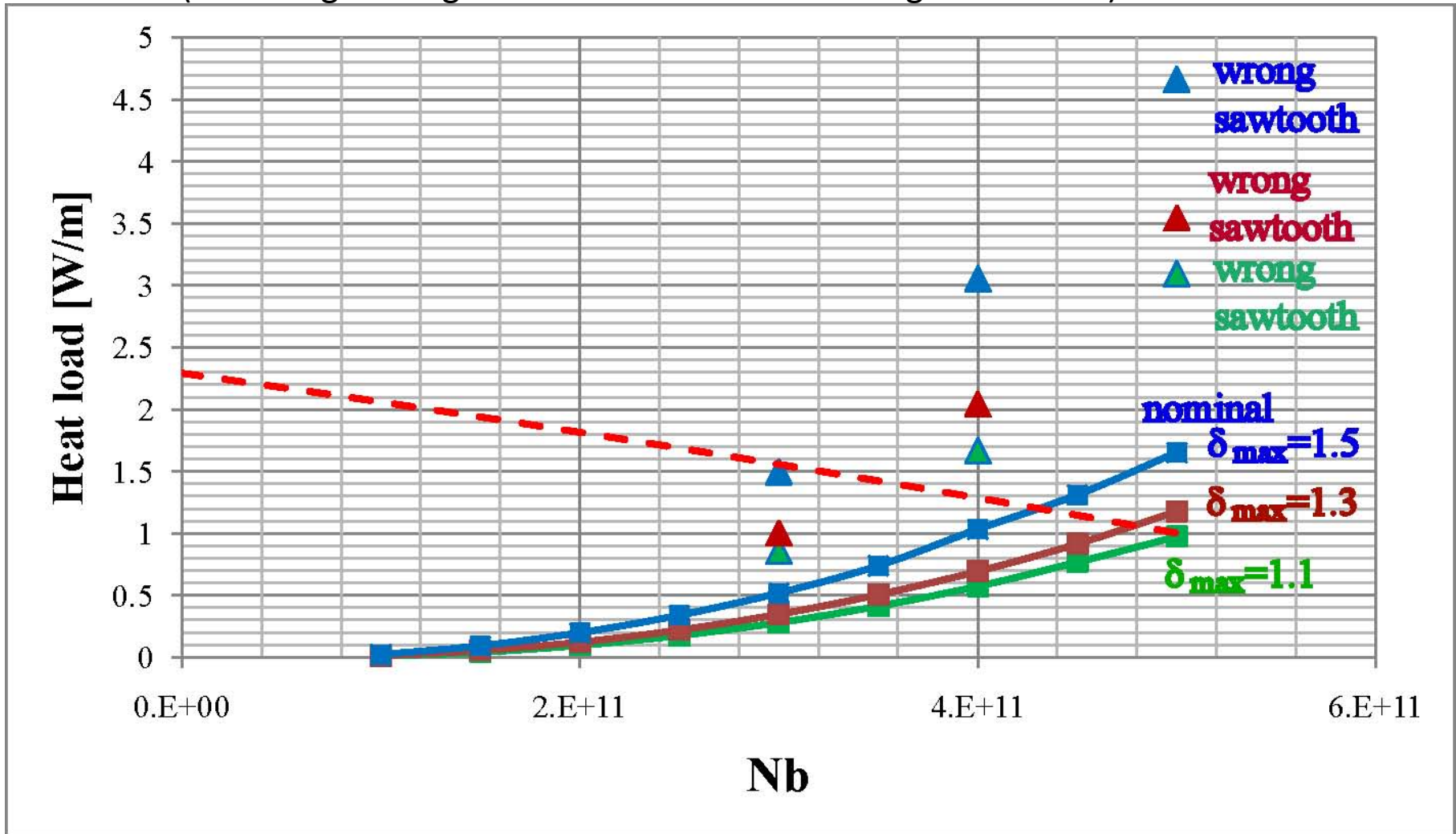
for $\delta_{max}=1.5$: $N_{max} \sim 1.2 \times 10^{11} \rightarrow 1.0 \times 10^{11}$

for $\delta_{max}=1.3$: $N_{max} > 2 \times 10^{11} \rightarrow 1.6 \times 10^{11}$

for $\delta_{max}=1.1$: $N_{max} \gg 2 \times 10^{11} \rightarrow 2.0 \times 10^{11}$

50-ns flat-bunch upgrade scenario (LPA)

local limit (assuming all magnets in 1 half cell have wrong orientation)



for $\delta_{max}=1.5$: $N_{max} \sim 4.3 \times 10^{11} \rightarrow 3.0 \times 10^{11}$

for $\delta_{max}=1.3$: $N_{max} \sim 4.8 \times 10^{11} \rightarrow 3.4 \times 10^{11}$

for $\delta_{max}=1.1$: $N_{max} \sim 5.0 \times 10^{11} \rightarrow 3.6 \times 10^{11}$

warning: I did not recover Humberto's results here; nevertheless I scaled from them

conclusions

- photon data are incomplete and inconsistent
- there is an impact on the local heat load, especially for the upgrade ; effect is 10-30% at most
- no more than one dipole per half cell (local cooling loop) should be installed with wrong beam-screen orientation if possible